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Bachtold, M.; Emmenegger, M.; Korvink, J.G.; Baltes, H.;
Computer-Aided Design of Integrated Circuits and Systems, IEEE on
Volume 16, Issue 12, Dec. 1997 Page(s):1439 - 1446
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- ☒ 2. **Low-order models for fast dynamical simulation of MEMS micromachined sensors**
Hung, E.S.; Yao-Joe Yang; Senturia, S.D.;
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 Innocent, M.; Wambacq, P.; Donnay, S.; Tilmans, H.A.C.; Sanser H.;
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